

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
UNITED STATES PATENT APPLICATION FOR  
MAGNETIC WAFER SEAL  
OF  
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BACKGROUND OF THE INVENTION

[0001] This application claims the benefit of U.S. Provisional Application No. 60/450,154, filed February 26, 2003.

(a) Field of the Invention

[0002] The present invention relates to a flexible magnetic wafer seal for adhesive attachment to folded pieces, such as brochures, folded cards, self-mailers and postal mailers, which are generally made of card stock. One or more flexible magnetic wafer seals may be adhesively attached to the open edges of a folded piece to secure the open edges together, for example, as required during the mailing process. The magnetic wafer seal can then be broken, preferably along at least one line of weakness, allowing the piece to be unfolded and converting the magnetic wafer seal into at least two magnetic holders for securing a piece to a metal surface. The unfolded piece can then be secured to a metallic surface by placing the side of the piece with the magnetic holders against the metallic surface, thereby allowing the magnetic holders to engage the metal surface, holding the piece in place.

(b) Description of the Prior Art

[0003] U.S. Pat. No. 1,938,654 to C. T. Braren teaches a machine for closing and sealing cartons, particularly cigarette cartons.

[0004] U.S. Pat. No. 2,056,451 to A. H. Haberstump teaches an apparatus for automatically stretching and securing a layer of fabric trim material over a padded backing sheet.

[0005] U.S. Pat. No. 2,388,770 to E. L. Stein teaches a method for sealing of mailing pieces by means of a small piece of gummed tape applied across the joint to be closed and sealed.

[0006] U.S. Pat. No. 2,854,164 to L. Triolo teaches a high speed machine for applying short lengths or tabs of tape having a coating of pressure sensitive adhesive thereon to box blanks or other articles.

[0007] U.S. Pat. No. 4,004,962 to Kleid teaches an automatic machine which utilizes sealing tape to seal the edges of a folded article passing therethrough.

[0008] U.S. Pat. No. 4,160,687 to Spear teaches an apparatus for applying labels across the pages of a magazine as it is being conveyed with the binding of the magazine first.

[0009] U.S. Pat. No. 5,054,757 to Martin et al. teaches an apparatus for producing mail pieces and a system and method for controlling the apparatus to produce mail pieces in a variety of configurations.

[0010] U.S. Pat. No. 5,185,983 to Slater teaches a machine comprising a pair of rolls on powered shafts for forming a tight fit between a wafer seal and a form piece as they move between the rolls.

[0011] U.S. Pat. No. 5,547,175 to Graushar et al. teaches a system for preparing mail products having an arrangement for folding each of the mail products at least once and externally applying a self-adhesive label around each of the mail products after folding.

[0012] U.S. Pat. No. 5,891,300 to Oussani, Jr. et al. teaches a tabbing machine for applying adhesive tabs over the edge of an article.

[0013] Businesses often advertise by sending coupons, promotional materials, flyers, and other types of advertising materials through the U.S. mail or by inserting

them between the pages of newspapers. These folded and sealed pieces are either mailed in envelopes, which may contain other types of advertising material, or are mailed or delivered as folded and sealed pieces which do not employ an envelope. The U.S. Postal Service has enacted rules specifying how the open edges of unenveloped pieces must be secured (tabbed) to prevent an open edge from jamming high-speed mail processing and sorting equipment. These rules are enumerated in the Domestic Mail Manual Quick Service Guide 811, "Tabs and Wafer Seals," incorporated herein by reference. Construction of the piece plays an important role in determining automation compatibility. Standards for tabbing are based on basis weight of paper stock used and the location of the folded or bound edge. The sealing method used to secure the folded edges of the piece can employ glue, tape, or wafer seals. To open the piece, the consumer merely breaks the seal on the edges of the piece and unfolds the piece.

[0014] Applicant is aware of no prior art where a magnetic wafer seal can be used to seal a piece and then be converted into at least two magnetic holders for securing a piece to a metal surface by breaking the magnetic wafer seal, preferably along at least one line of weakness arranged across the wafer seal.

#### SUMMARY OF THE INVENTION

[0015] The present invention relates to a magnetic wafer seal for adhesive attachment to folded pieces, such as brochures, folded cards, self-mailers and postal mailers. In the preferred embodiment, the magnetic wafer seal is composed of a thin, relatively flat, flexible magnet having an upper surface, a lower surface, a thickness between said upper surface and said lower surface, two lines of weakness comprised of variably spaced perforations which extend across the upper surface and at least partially through the magnet thickness towards the lower surface, and an adhesive

layer affixed to the lower surface. The two lines of weakness, which intersect at their respective mid-points and form four approximately 90 degree angles between them, are comprised of a multiplicity of variably spaced perforations. Each of the multiplicity of perforations has either a first spacing or a second spacing between adjacent perforations. The magnetic wafer seal may be attached to and seal the edges of a folded piece by adhering the adhesive layer to the edges of the piece. The magnetic wafer seal can then be converted into at least two magnetic holders for securing the piece to a metal surface by breaking, tearing, or otherwise severing the magnetic wafer seal to form the magnetic holders.

[0016] It is often the hope of the business producing or sending the piece that the consumer will retain the piece and post it in a conspicuous place, such as a bulletin board or refrigerator. Small, flexible magnets have become very popular with consumers, who use them as "refrigerator magnets" to hold coupons, advertisements, promotional material, postcards, etc. on their home refrigerator. Consequently, there is a need for flexible wafer seals which can be adhesively attached to folded card stock or other material used for advertising pieces to secure the open edges and which can subsequently be used to magnetically attach the unfolded piece to a metal object, such as a refrigerator, when the seal is broken.

[0017] A principal object and advantage of the present invention is that the magnetic wafer seal can be used to secure the edges of a piece and then be converted into at least two magnetic holders for securing a piece to a metal surface by breaking, tearing, or otherwise severing the wafer seal to form the magnetic holders.

[0018] An additional object and advantage of the present invention is that the magnetic wafer seal is easily manufactured in volume, is flexible enough to be folded over

and be easily adhered in that position, is thin enough not to adversely impact a U.S. Postal Service automatic mail sorting machine, and is easily applicable to the edges of the piece.

[0019] An additional object and advantage of the present invention is that the magnetic wafer seal has sufficient strength to survive mailing but is easily broken or torn when upward or sideways pressure is applied to it so that the consumer may unseal the sealed edges of the piece without tearing the piece when such pressure is applied.

[0020] An additional object and advantage of the present invention is that when the magnetic wafer seal is folded along a line of weakness, the line of weakness enhances the ability of the magnetic wafer seal to stay folded and not resume a flat position.

[0021] An additional object and advantage of the present invention is that the magnetic wafer seal of the preferred embodiment, and many of the alternate embodiments, may be utilized with existing tabbing machines by reconfiguring the tabbing machine to accept and apply the label.

#### BRIEF DESCRIPTION OF THE DRAWINGS

[0022] A better understanding of the present invention will be had upon reference to the following description in conjunction with the accompanying drawings, wherein:

[0023] Figure 1 is a top perspective view of the magnetic wafer seal of the present invention on a liner, depicting a magnet with two intersection lines of weakness comprised of variably spaced perforations and an adhesive layer;

[0024] Figure 2 is a top view of a multiplicity of the magnetic wafer seals of Figure 1;

[0025] Figure 3 is a top view of a multiplicity of an alternate embodiment of the magnetic wafer seal of Figure 1, having a different shape;

[0026] Figure 4 is a top view of a multiplicity of an

alternate embodiment of the magnetic wafer seal of Figure 1, having a different shape;

[0027] Figure 5 is a top view of a multiplicity of an alternate embodiment of the magnetic wafer seal of Figure 1, having a different shape;

[0028] Figure 6 is a top view of the magnet of Figure 1, showing the varied spacing of the perforations comprising the two lines of weakness;

[0029] Figure 7 is a top view of a multiplicity of an alternate embodiment of the magnetic wafer seal of Figure 1, where the two lines of weakness extend only partially across the magnet;

[0030] Figure 8 is a top perspective view of an alternate embodiment of the magnetic wafer seal of Figure 1, having two lines of weakness comprised of evenly spaced perforations;

[0031] Figure 9 is a top perspective view of an alternate embodiment of the magnetic wafer seal of Figure 1, having one line of weakness comprised of variably spaced perforations;

[0032] Figure 10 is a top perspective view of an alternate embodiment of the magnetic wafer seal of Figure 1, having one line of weakness comprised of evenly spaced perforations;

[0033] Figure 11 is a top perspective view of an alternate embodiment of the magnetic wafer seal of Figure 1, having a scoreline;

[0034] Figure 12 is a top view of the magnet of Figure 11;

[0035] Figure 13 is a bottom view of the magnet of Figure 11;

[0036] Figure 14 is a top view of an alternate embodiment of the magnetic wafer seal of Figure 1 having a line of weakness composed of one or more slits;

[0037] Figure 15 is a top view of a multiplicity of an alternate embodiment of the magnetic wafer seal of Figure 1, having a different shape;

[0038] Figure 16 is a front perspective view of a multi-page piece prior to sealing, folded into three sections and having two magnetic wafer seals of Figure 4 affixed to an outside end edge;

[0039] Figure 17 is a front perspective view of a multi-page piece prior to sealing, folded into two sections and having two magnetic wafer seals of Figure 1 each affixed to an outside side edge;

[0040] Figure 18 is a front view of a piece prior to sealing, folded into two sections and having one magnetic wafer seal of Figure 5 affixed to an outside end edge;

[0041] Figure 19 is a front view of the piece of Figure 16, where the piece is unsealed and unfolded and has four magnetic holders;

[0042] Figure 20 is a front view of the piece of Figure 17, where the piece is unsealed and unfolded and has four magnetic holders;

[0043] Figure 21 is a front view of the piece of Figure 18, where the piece is unsealed and unfolded and has two magnetic holders;

[0044] Figure 22 is a front perspective view of a piece prior to sealing, folded into three sections and having one magnetic wafer seal of Figure 3 affixed to an outside end edge;

[0045] Figure 23 is a front view of the piece of Figure 22, where the piece is unsealed and unfolded and has two magnetic holders;

[0046] Figure 24 is a front perspective view of a piece after sealing, folded into two sections and having the magnetic wafer seal of Figure 1 affixed to two outside end edges; and

[0047] Figure 25 is an end view of the piece of Figure 24.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENT

[0048] With reference to the figures, Figure 1 shows a magnetic wafer seal 10 which is the preferred embodiment of the present invention removably adhesively affixed to liner 8. The magnetic wafer seal 10 is composed of a thin, relatively flat, flexible magnet 20 having an upper surface 24, a lower surface 26, a thickness 22 between said upper surface 24 and said lower surface 26, at least one line of weakness comprising two intersecting lines of weakness 50, 52 extending substantially across the magnet upper surface 24, and an adhesive layer 70 affixed to the lower surface 26. In the preferred embodiment, the two intersecting lines of weakness 50, 52 extend at least partially and preferably completely through the magnet thickness 22 towards the magnet lower surface 26. The two lines of weakness 50, 52 intersect at their respective mid-points 56 and form four approximately 90 degree angles between them. Each of the two lines of weakness 50, 52 are comprised of a multiplicity of variably spaced perforations 60 which extend at least partially through the magnet thickness 22 towards the lower surface 26, and each of the multiplicity of perforations 60 have either a first spacing 62 or a second spacing 64 between adjacent perforations 60.

[0049] Figure 2 shows a multiplicity of the magnetic wafer seals 10 of Figure 1 removably adhesively affixed to liner 8. Figures 3-5 show alternate embodiments of the magnetic wafer seal 110-310 removably adhesively affixed to liner 8, where the magnets 120-320 have differing shapes. The magnetic wafer seal 10 may be adhesively attached to a piece 1 by applying the adhesive layer 70 side to the piece 1. Figures 24 and 25 show the magnetic wafer seal 10 of Figure 1 attached to a folded piece 1.

[0050] As shown in Figure 1, the magnet 20 of the



preferred embodiment of the magnetic wafer seal 10 is circular in shape with a preferential diameter, for example, in the range of approximately 1.905 centimeters (0.75 inch) to 2.858 centimeters (1.125 inches), and the magnet 20 has a preferential thickness 22 in the range of approximately 0.305 millimeters (0.012 inch; 12 mils) to 0.381 millimeters (0.015 inch; 15 mils) for example. This thickness 22 allows the magnetic wafer seal 10 to be flexibly attached to a piece 1 and to be easily torn along at least one line of weakness 50, 52. Magnetic wafer seals having other size, shape or thickness can be used, such as in the magnetic wafer seals 10, 110, 210, 310, 410, 510, 610, 710, 810, 910, and 1010 described herein, so long as there is sufficient magnetic strength to secure or hold a piece 1 against a horizontal metallic surface. The magnet 20-1020 shown in the various embodiments herein is preferably die cut or stamped from a known thin sheet of flexible magnetic material, such as a vinyl material having magnetic material dispersed therethrough. Such a sheet of flexible magnetic material can be obtained under the trademark "UltraMag" from Flex-Mag Industrial, Inc., of Marietta, Ohio. Depending on the magnetic capabilities of the magnetic material and the weight of the item to be magnetically affixed, the magnet 20-1020 size and thickness 22-622 can be varied. For example, the magnet 20-1020 diameter or width could vary in size from 2.223 centimeters (0.875 inches) to 7.620 centimeters (3.0 inches) or larger as necessary for use with heavier pieces 1. Additionally, the magnetic wafer seal 10-1010 can be made in any number of geometric shapes such as those shown in Figures 1-6 and 15, where the magnet 20-320, 1020 has shapes which may include circles, squares, rectangles, rectangles with curved edges, ovals, elliptical shapes, hourglass shapes and figure eight shapes.

[0051] As clearly shown in Figures 1, 2 and 6, the magnet 20 of the preferred embodiment has two lines of weakness 50,

52 across the upper surface 24. The two lines of weakness 50, 52 extend at least partially through the magnet thickness 22 towards the lower surface 26. The two lines of weakness 50, 52 intersect at their respective mid-points 56, forming four approximately 90 degree angles therebetween. Each line of weakness 50, 52 is comprised of a multiplicity of preferably variably spaced perforations 60 which extend at least partially through the magnet thickness 22 from the upper surface 24 toward the lower surface 26.

[0052] As shown in Figures 1, 2 and 6, the two lines of weakness 50, 52 preferably extend substantially across the center of the upper surface 24 of the magnet 20 and intersect at their respective mid-points 56, forming four approximately 90 degree angles therebetween and dividing the upper surface 24 into substantially equally sized quarter sections. However, the two lines of weakness 50, 52 may be in any orientation in regard to the edge of the liner 8, which is removably attached to the adhesive layer during production of the magnetic wafer seal 10. The two lines of weakness 50, 52 may also be in any position on the upper surface 24, and may intersect at any angle in order to accommodate the configuration of the tabbing machine to be used.

[0053] As shown in Figures 1, 2 and 6, the two lines of weakness 50, 52 in the preferred embodiment are comprised of a multiplicity of variably spaced perforations 60, which extend from the upper surface 24 through the magnet thickness 22 toward the lower surface 26. The perforations 60 preferably extend fully through the thickness 22 of the magnet 20, but may extend only partially through the magnet thickness 22. If the perforations 60 do not extend fully through the magnet thickness 22, the perforations 60 are preferably at least 0.127 to 0.229 millimeters (0.005 to .009 inch; 5 to 9 mils) deep, when the thickness 22 of magnet 20 is 0.305 millimeters (0.012 inch; 12 mils).

[0054] In the preferred embodiment, the multiplicity of perforations 60 comprising lines of weakness 50, 52 each have a spacing between adjacent perforations 60, preferably comprising either a first spacing 62 having a first shorter length or a second spacing 64 having a second longer length. The first spacing 62 may be of any length which allows a consumer to easily tear the magnetic wafer seal 10 along a line of weakness 50, 52. The first spacing 62 preferably has a length in the approximate range of 0.106 centimeter (0.0417 inch) to 0.159 centimeter (0.0626 inch). The second spacing 64 may be of any length which both allows a consumer to easily tear the magnetic wafer seal 10 along a line of weakness 50, 52 and provides an area of strength to the line of weakness 50, 52 to assist in maintaining the integrity of the magnetic wafer seal 10 when folded and prior to the consumer intentionally breaking the line of weakness 50, 52. The second spacing 64 preferably has a length in the approximate range of 0.3175 centimeter (0.125 inch) to 0.635 centimeter (0.250 inch). When the magnetic wafer seal 10 is folded along one of the lines of weakness 50, 52, as shown in Figures 24 and 25, that line of weakness 50, 52 along the fold decreases the tendency for the magnetic wafer seal 10 to unfold because it decreases the ability of the magnet 20 to resume a flat position.

[0055] Figure 6 depicts a top view of the magnet 20 of Figure 1, showing two lines of variably spaced perforations 60 extending fully across the magnet 20 upper surface 24. As best shown in Figure 6, the variable spacing of the perforations 60 allows a number of perforations 60, preferably five to seven, to each be tightly spaced apart from an adjacent perforation by a first length 62, which comprises an area of weakness 66 in the line of weakness 50, 52. An area of weakness 66 is bounded on both ends by a perforation 60 and is spaced apart from another area of weakness 66 by a second spacing 64. The second spacing 64

forms an area in the line of weakness 50, 52 which has a longer length which is not perforated and is therefore stronger than the areas of weakness 66. There are preferably at least two second spacings 64 in each line of weakness 50, 52. The perforations 60 closest to the edges of magnet 20 in lines of weakness 50, 52 preferably cut the magnet 20 along thickness 22. This makes the magnetic wafer seal 10 easier to separate along lines of weakness 50, 52.

[0056] Figure 7 depicts an alternate embodiment of the magnetic wafer seal 410, in which the magnetic wafer seal 410 is composed of a thin, relatively flat, flexible magnet 420 having an upper surface 124, a lower surface 26 (not shown), a thickness 122 (not shown) between said upper surface 124 and said lower surface 26, two lines of weakness 150, 152 comprised of a multiplicity of spaced perforations 60 extending partially across the magnet upper surface 124, and an adhesive layer 70 (not shown) affixed to the lower surface 26. In this embodiment, the at least one line of weakness comprises two intersecting lines of weakness 150, 152 which extend at least partially through the magnet thickness 122 towards the magnet lower surface 26. The two lines of weakness 150, 152 intersect and form four approximately 90 degree angles therebetween. Each of the two lines of weakness 150, 152 are comprised of a multiplicity of evenly spaced perforations 60 which extend at least partially through the magnet thickness 122 towards the lower surface 26, and each of the multiplicity of perforations 60 have a first spacing 62 between adjacent perforations 60. The first spacing 62 may be of any length which allows a consumer to easily tear the magnetic wafer seal 410 along a line of weakness 150, 152. A second spacing 64, which is longer than the first spacing 62, is adjacent to the last of the multiplicity of perforations 60 in the lines of weakness 150, 152. The second spacing 64 may also be of any length which both provides an area of

strength to the line of weakness 50 and allows a consumer to easily tear the magnetic wafer seal 410 along the line of weakness 50. After removal from the liner 8, the magnetic wafer seal 410 may be adhesively attached to a piece 1 by applying the adhesive layer 70 side to the piece 1.

[0057] Figure 8 depicts an alternate embodiment of the magnetic wafer seal 510, in which the magnetic wafer seal 510 is composed of a thin, relatively flat, flexible magnet 520 having an upper surface 224, a lower surface 26, a thickness 222 between said upper surface 224 and said lower surface 26, two lines of weakness 250, 252 comprised of a multiplicity of evenly spaced perforations 60 extending substantially across the magnet upper surface 224, and an adhesive layer 70 affixed to the lower surface 26. In this embodiment, the at least one line of weakness comprises two intersecting lines of weakness 250, 252 which extend at least partially through the magnet thickness 222 towards the magnet lower surface 26. The two lines of weakness 250, 252 intersect at their respective mid-points 256 and form four approximately 90 degree angles therebetween. Each of the two lines of weakness 250, 252 are comprised of a multiplicity of evenly spaced perforations 60 which extend at least partially through the magnet thickness 222 towards the lower surface 26, and each of the multiplicity of perforations 60 have a first spacing 62 between adjacent perforations 60. The first spacing 62 may be of any length which allows a consumer to easily tear the magnetic wafer seal 510 along a line of weakness 250, 252. After removal from the liner 8, the magnetic wafer seal 510 may be adhesively attached to a piece 1 by applying the adhesive layer 70 side to the piece 1.

[0058] Figure 9 depicts an alternate embodiment of the magnetic wafer seal 610, in which the magnetic wafer seal 610 is composed of a thin, relatively flat, flexible magnet 620 having an upper surface 324, a lower surface 26, a

thickness 322 between said upper surface 324 and said lower surface 26, one line of weakness 50 comprised of a multiplicity of variably spaced perforations 60 extending substantially across the magnet upper surface 324, and an adhesive layer 70 affixed to the lower surface 26. The at least one line of weakness in this embodiment comprises one line of weakness 50 which extends at least partially through the magnet thickness 322 towards the magnet lower surface 26. The line of weakness 50 is comprised of a multiplicity of variably spaced perforations 60 which extend at least partially through the magnet thickness 322 towards the lower surface 26, and each of the multiplicity of perforations 60 have either a first spacing 62 having a first shorter length or a second spacing 64 having a second longer length between adjacent perforations 60. The first spacing 62 may be of any length which allows a consumer to easily tear the magnetic wafer seal 610 along the line of weakness 50. The second spacing 64 may also be of any length which both allows a consumer to easily tear the magnetic wafer seal 610 along the line of weakness 50 and provides an area of strength to the line of weakness 50 to assist in maintaining the integrity of the magnetic wafer seal 610 when folded and prior to the consumer intentionally breaking the line of weakness 50, and provides an area of strength to the line of weakness 50. After removal from the liner 8, the magnetic wafer seal 610 may be adhesively attached to a piece 1 by applying the adhesive layer 70 side to the piece 1.

[0059] Figure 10 depicts an alternate embodiment of the magnetic wafer seal 710, in which the magnetic wafer seal 710 is composed of a thin, relatively flat, flexible magnet 720 having an upper surface 424, a lower surface 26, a thickness 422 between said upper surface 424 and said lower surface 26, one line of weakness comprised of evenly spaced perforations 60 extending substantially across the magnet upper surface 424, and an adhesive layer 70 affixed to the

lower surface 26. The one line of weakness 250 extends at least partially through the magnet thickness 422 towards the magnet lower surface 26. The line of weakness 250 is comprised of a multiplicity of evenly spaced perforations 60 which extend at least partially through the magnet thickness 422 towards the lower surface 26, and each of the multiplicity of perforations 60 have a first spacing 62 between adjacent perforations 60. The first spacing 62 may be of any length which allows a consumer to easily tear the magnetic wafer seal 710 along the line of weakness 250. After removal from the liner 8, the magnetic wafer seal 710 may be adhesively attached to a piece 1 by applying the adhesive layer 70 side to the piece 1.

[0060] Figure 11 is a top perspective view of an alternate embodiment of the magnetic wafer seal 810 of the present invention, depicting a magnet 820 having an upper surface 524, a lower surface 26, a thickness 522 between said upper surface 524 and said lower surface 26, at least one line of weakness comprising a scoreline 350 which extends at least partially through the magnet thickness 522 towards the lower surface 26, and an adhesive layer 70 affixed to the lower surface 26. As shown in Figure 11 the at least one line of weakness 350 is comprised of a scoreline 350, which is a cut line that does not extend fully through the thickness 522 of the magnet 820. For a magnet 820 having a thickness 522 of about 0.305 millimeters (0.012 inch or 12 mils), the scoreline 352 is preferably 0.0762 millimeters (0.003 inch; 3 mils) to 0.229 millimeters (0.009 inch; 9 mils) deep, and more preferably 0.127 millimeters (0.005 inch; 5 mils) to 0.178 millimeters (0.007 inch; 7 mils) deep. Figure 12 depicts a top view of the magnet 820 of Figure 11, with the magnet 820 having a scoreline 350 extending fully across its upper surface 524. Figure 13 depicts the lower surface 26 of the magnet 820 of Figure 11, showing that the scoreline 350 does not extend

entirely through the magnet thickness 822 and does not extend through the lower surface 26. Alternatively, the at least one line of weakness may comprise two intersecting scorelines 350, 352 which extend at least partially through the magnet thickness 522 towards the magnet lower surface 26 (not shown). The two scorelines 350, 352 intersect at their respective mid-points 356 and form four approximately 90 degree angles therebetween (not shown).

[0061] Figure 14 depicts an alternate embodiment of the magnet 920 of the magnetic wafer seal 910 of Figure 10, where the at least one line of weakness 450 is comprised of one line consisting of one or more slits 160 which extend at partially across the magnet 920 upper surface 624 and which extend at least partially or completely through the magnet thickness 622 (not shown). Alternatively, the at least one line of weakness may comprise two intersecting lines 450, 452 consisting of one or more slits which extend at least partially or completely through the magnet thickness 622. The two lines 450, 452 intersect at their respective mid-points 456 and form four approximately 90 degree angles therebetween (not shown).

[0062] Figure 15 depicts an alternate embodiment of the magnetic wafer seal 1010 of Figures 9-11 and 14, where the magnet 1020 has an hour-glass shape. The at least one line of weakness comprises one line of weakness which consists of a score-line 350 extending across the narrowest area of the upper surface 724, as depicted in Figure 15, but the one line of weakness 350 may also be comprised of variably or evenly spaced perforations 60 or slits 160 extending substantially across the narrowest area of the upper surface 724.

[0063] Additionally, as shown in the figures, all embodiments of the magnetic wafer seal 10-1010 can be made in any number of geometric shapes such as those shown in Figures 1-6 and 15, where the magnet 20-320, 1020 has shapes



which may include circles, squares, rectangles, rectangles with curved edges, ovals, elliptical shapes, hourglass shapes and figure eight shapes.

[0064] Magnet 1020 shapes such as the hourglass shape depicted in Figure 15 allow the size of the magnetic wafer seal 1010 which is adhesively applied to the piece 1 to be maximized, while the length of that portion of the magnet 1020 to be torn by the consumer is minimized. For example, the narrow area of the magnet 1020 which is to be torn by the consumer could be sized to be only .635 centimeter (0.250 inch) to 1.27 centimeters (0.500 inch) wide.

[0065] In each of the embodiments of the magnetic wafer seal 10-1010 of Figures 1-15, and as shown in Figures 1 and 8-11, a layer of adhesive 70 is affixed to the lower surface 26 of the magnet 20-1020. The adhesive layer 70 is preferably about 0.0762 millimeters (0.003 inch; 3 mils) thick, although it may be thinner or thicker as required by the application. The adhesive is preferably a permanent adhesive with a minimum adhesive or shear strength value of at least 425.25 grams (15 ounces) per 2.54 centimeters (1 inch) at a speed of 30.48 centimeters (12 inches) per minute after application to a stainless steel plate; however any suitable adhesive may be used. The adhesive layer 70 is attached to and covered by a removable liner 8. The liner 8 is preferably comprised of paper, plastic or vinyl, although it may be made of any suitable material. The liner 8 allows the magnet 20-1020 and adhesive layer 70 to be removed as a unit, forming a magnetic wafer seal 10-1010.

[0066] One method for forming the magnetic wafer seal 10-1010 of all embodiments of the present invention (Figures 1-15), including the preferred embodiment of the magnetic wafer 10 of Figure 1, is as follows: a layer 70 of the adhesive material is applied to a liner 8. A layer of magnetic material is then applied over the liner 8 onto the adhesive layer 70. The magnetic material is then die cut

into a chosen shape to the depth of, but not through, the liner 8, cutting one or more magnets 20-1020 into the magnetic material, and the extra magnetic material is detached from the liner 8, leaving at least one magnetic wafer seal 10-1010 removably adhesively attached to the liner 8. The at least one line of weakness 50-450, 52-452 is added during the die cutting process. The first spacings 62 are formed by the spacings between the perforation needles used to create the at least one line of weakness 50-250, 52-252, and the second spacings 64 in the at least one line of weakness 50-150, 52-152 are formed by removing one or more corresponding perforating needles from the row of perforation needles installed in the needle head. The perforations 60 closest to the edges of magnet 20-1020 in lines of weakness 50-250, 52-252 preferably cut the magnet 20-1020 along thickness 22-522. This makes the magnetic wafer seal 10-1010 easier to separate along lines of weakness 50-250, 52-252.

[0067] The at least one line of weakness 50-450, 52-452 on the magnetic wafer seal 10-1010 may be oriented in relation to the liner 8 in any orientation which is required by the tabbing machine being used (see Figures 1-5 and 8-11). Where two lines of weakness 50, 52 are employed (Figures 1-5, 7, 8), one line of weakness 50-450 can be aligned parallel to the edges of the liner 8 and the other line of weakness 52-452 can be aligned perpendicular to the edges of the liner 8. Where one line of weakness 50-450 is employed as in Figure 9-11, the line of weakness 50-450 can be aligned either parallel to the edges of the liner 8 (Figures 9 and 10) or perpendicular to the edges of the liner 8 (Figure 11). Additionally, any other orientation of the at least one line of weakness 50-450, 52-452 required by the tabbing process may be employed. The magnetic wafer seal 10 of the preferred embodiment and all of the alternate embodiments 10-1010 of the present invention (Figures 1-5,

7-11 and 14), with the exception of the embodiment 1010 of Figure 15 which has an hourglass shape, may be utilized with existing tabbing machines by reconfiguring the tabbing machine to accept and apply the label. For those magnetic wafer seals 10-1010 employed on pieces 1 to be mailed, the magnetic wafer seal 10-1010, including the magnet 20-1020 and the adhesive layer 70, must have sufficient strength and holding power to hold the piece 1 sealed in a unitary folded piece 1 without the piece 1 losing form or unsealing during the mail processing by the United States Postal Service.

[0068] In each of the embodiments, the magnetic wafer seal 10-1010 may be adhesively applied to a piece 1 by removing the magnetic wafer seal 10-1010 from the liner 8, then applying the adhesive layered 70 side of a portion of the magnetic wafer seal 10-1010 to two outer open edges 3 of the piece 1 so that the magnetic wafer seal 10-1010 is folded over and adhered to the outer surface 5 of the piece 1, thereby holding the piece edges 3 together and sealing them.

[0069] As depicted in Figures 24 and 25, the at least one line of weakness 50-450, 52-452 in the magnet 20-1020 serves as a fold line and allow the magnetic wafer seal 10-1010 to be easily folded along any of the at least one lines of weakness 50-450, 52-452, wherein the portions of the upper surface 24-624 on either side of the folded line of weakness 50-450, 52-452 are pressed towards each other, bringing portions of the lower surface 26 in proximity to each other.

[0070] Figures 17-18 show a one or more of the magnetic wafer seals 810, 310 partially adhesively applied to one or more outer edges 3 of a piece 1, prior to sealing the piece 1 by folding the piece 1 along the a fold line 7 and folding the magnetic wafer seal 10-1010 along one of the at least one line of weakness 50-450, 52-452 and adhesively attaching another portion of the magnetic wafer seal 10-1010 to a second outer edge 3. Folding the magnetic wafer seal 10-

1010 along the at least one line of weakness 50-450, 52-452 also permits the magnetic wafer seal 10-1010 to stay in the folded position. Additionally, as shown in Figures 16 and 22, the magnetic wafer seal 10-1010 may be adhesively attached to an outer edge 3 and an outer surface 5 of the piece 1 in order to seal the piece 1. The process of sealing the piece 1 by application of the magnetic wafer seal 10-1010 may be used for any of the embodiments of Figures 1 - 15.

**[0071]** The consumer unseals the piece 1 by tearing or breaking the magnetic wafer seal 10-1010 of any of the embodiments of the present invention along the line or lines of weakness 50-450, 52-452 and then unfolding the folds 7 of the piece 1. As shown in Figures 19-21 and 23, this action converts the magnetic wafer seal 10-1010 into at least two magnetic holders 92-392, 94-394 for securing a piece 1 to a metallic surface. The unfolded piece 1 can then be secured to a metallic surface by placing the outer surface 5 of the piece 1 containing the magnetic holders 92-392, 94-394 against the metallic surface, thereby allowing the magnetic holders 92-392, 94-394 to engage the metallic surface, holding the piece 1 in place.

**[0072]** A plurality of magnetic wafer seals 10-1010 could be employed to seal the piece 1. For example, two or more magnetic wafer seals 10-1010 could be placed along the end edge 3 of the piece 1 (Figure 16), one or more could be placed along the open side edge 3 or edges 3 of the piece 1 (Figure 17) or one or more could be used to seal an edge 3 of the substrate against a surface 5 of the substrate (Figures 16 and 22).

**[0073]** The foregoing detailed description is given primarily for clearness of understanding and no unnecessary limitations are to be understood therefrom, for modifications can be made by those skilled in the art upon

reading this disclosure and may be made without departing from the spirit of the invention.